



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:
Jean Seydoux et al.

Serial No.: 10/707,985

Filed: January 29, 2004

For: Systems for Deep Resistivity while Drilling for Proactive
Geosteering

) Docket No.: 24.0897

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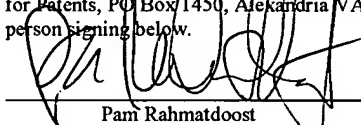
) Group Art Unit:

)

) Confirmation No. 1984

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) Examiner:

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INFORMATION DISCLOSURE STATEMENT

Dear Sir:

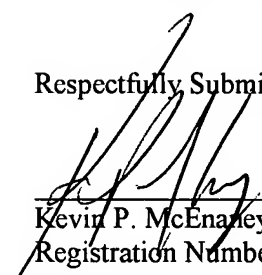
The following documents on the Form PTO-1449 are submitted to the United States Patent and Trademark Office under provisions of 37 CFR 1.97-1.98. A copy of each reference is enclosed.

Please charge any necessary fees to the deposit account for Schlumberger Technology Corporation, Account No. 19-0610.

Respectfully Submitted,

Date:

Feb. 6, 2004


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FORM PTO-1449 (Modified)

ATTY. DOCKET NO.
24.0897SERIAL NO.
10/707,985LIST OF INFORMATION PROVIDED
BY APPLICANT

Use several sheets if necessary)

APPLICANT: Jean Seydoux et al.

FILING DATE:
January 29, 2004

GROUP

REFERENCE DESIGNATION U.S. PATENT DOCUMENTS

Examiner Initial		Document No.	Date	Patentee
	AA			
	AB			
	AC			
	AD			
	AE			
	AF			
	AG			
	AH			
	AI			

FOREIGN PATENT DOCUMENTS

		Document No.	Date	Country	Translation Yes No	
	AL	GB 2301902	12/18/96	United Kingdom		
	AM					
	AN					
	AO					

OTHER INFORMATION PROVIDED (AUTHOR, TITLE, DATE, PLACE OF PUBLICATION, PERTINENT PAGES,
ETC.)

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EXAMINER

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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.

1. The attached cited information should not be construed as an admission that any of the above items are prior art to the subject invention.

